

Title (en)

Energy resolved emission microscopy system and method.

Title (de)

Emissionsmikroskop.

Title (fr)

Microscope à émission.

Publication

EP 0559313 A1 19930908

Application

EP 93300288 A 19930118

Priority

US 82699292 A 19920128

Abstract (en)

An emission microscope system includes in various embodiments a catadioptric optical microscope and/or a computer automated optical dispensing system and/or a cryogenically cooled back thinned CCD camera. The system also includes a computer controlled data acquisition system with specially tailored software. <IMAGE>

IPC 1-7

G01N 21/88; **H04N 7/18**

IPC 8 full level

G01N 21/62 (2006.01); **G01R 31/302** (2006.01); **G02B 21/00** (2006.01); **H01L 21/66** (2006.01); **G01J 3/28** (2006.01); **G01J 3/443** (2006.01)

CPC (source: EP US)

G01N 21/62 (2013.01 - EP US); **G02B 21/00** (2013.01 - EP US); **G02B 21/0016** (2013.01 - EP US); **G01J 3/2803** (2013.01 - EP US); **G01J 3/443** (2013.01 - EP US)

Citation (search report)

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